

AF
1765

Corres. and Mail
BOX AF

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765

In re Application of:

Docket No. 03500.012395.1 (35.C12395CIP)

Yoshihiko FUKUMOTO

Application No.: 09/429,530

Examiner: Lan Vinh

Filed: October 28, 1999

Group Art Unit: 1765

For: METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE

Date: January 6, 2004

RECEIVED
JAN 09 2004
TC 1700

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment After Final Rejection in the above-identified application.

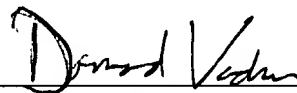
☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	1	MINUS	34	= 0	x \$9 \$18	-0-
INDEP. CLAIMS	1	MINUS	3	= 0	x \$42 \$84	-0-
Fee for Multiple Dependent claims \$140%/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						-0-

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$____ is enclosed.
- ☐ Charge \$____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$____ to cover the fee for a ____ month extension is enclosed.
- ☐ A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



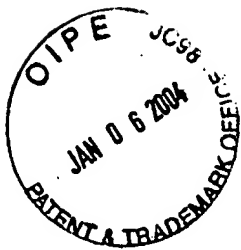
Attorney for Applicant

Damond E. Vadnais

Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

DEV/vc
DC_MAIN 154261v1



RECEIVED
JAN 0 9 2004
TC 1700

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765

03500.012395.1 (35.C12395CIP)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Lan Vinh
Yoshihiko FUKUMOTO)	
	:	Group Art Unit: 1765
Application No.: 09/429,530)	
	:	
Filed: October 28, 1999)	
	:	
For: METHOD FOR FABRICATING)	
SEMICONDUCTOR DEVICE	:	January 6, 2004

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action dated December 4, 2003, please amend the
above-identified application, as follows: